



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

## ELECTRONIC COPY

### LABORATORY GROWN DIAMOND REPORT

January 10, 2026

IGI Report Number

**LG757535216**

Description

**LABORATORY GROWN DIAMOND**

Shape and Cutting Style

**ROUND BRILLIANT**

Measurements

**12.96 - 13.03 X 7.67 MM**

### GRADING RESULTS

Carat Weight

**8.01 CARATS**

Color Grade

**E**

Clarity Grade

**VVS 2**

Cut Grade

**EXCELLENT**

### ADDITIONAL GRADING INFORMATION

Polish

**EXCELLENT**

Symmetry

**EXCELLENT**

Fluorescence

**NONE**

Inscription(s)

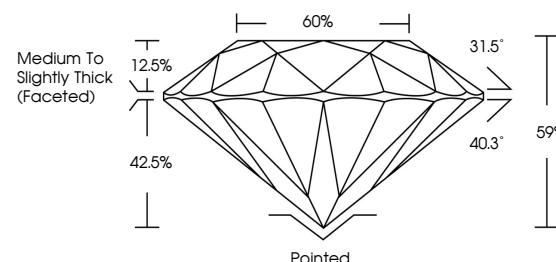
**IGI LG757535216**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

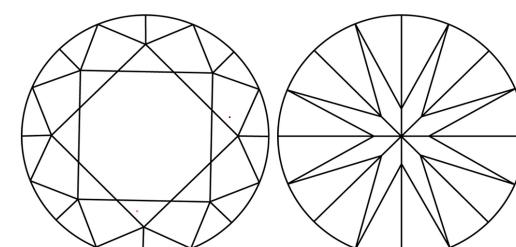
Type Ila

LG757535216  
Report verification at [igi.org](http://igi.org)

### PROPORTIONS



### CLARITY CHARACTERISTICS



### KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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### GRADING RESULTS

Carat Weight **8.01 CARATS**

**E**

Color Grade **VVS 2**

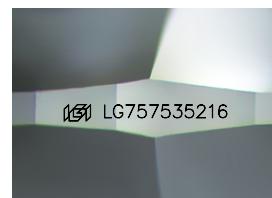
**EXCELLENT**

Clarity Grade **VVS 2**

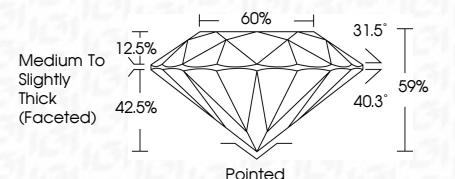
**EXCELLENT**

Cut Grade **EXCELLENT**

**EXCELLENT**



Sample Image Used



### ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

**EXCELLENT**

Symmetry **NONE**

**NONE**

Fluorescence **None**

**None**

Inscription(s) **IGI LG757535216**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila



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January 10, 2026  
IGI Report No LG757535216  
ROUND BRILLIANT  
12.96 - 13.03 X 7.67 MM  
Carat Weight: 8.01 CARATS  
Color Grade: E  
Clarity Grade: VVS 2  
Cut Grade: EXCELLENT  
Depth: 59%  
Girdle: Pointed  
Symmetry: EXCELLENT  
Fluorescence: None  
Inscription(s): IGI LG757535216  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type Ila